

SEMI North America Standards Spring 2020

Meeting Schedule

This schedule is subject to change without notice.

Due to the COVID-19 virus, all Technical Committee meetings are POSTPONED
Task Force meetings will still proceed as scheduled via Web conference

SEMI Staff:
JA = James Amiano
KN = Kevin Nguyen
LN = Laura Nguyen
IS = Inna Skvortsova

Monday, March 30, 2020

U.S. Pacific Time	7:00	8:00	9:00	10:00	11:00	12:00	13:00	14:00	15:00	16:00	17:00	18:00	19:00	20:00
Gases			Materials of Construction of Gas Delivery Systems (TF) 09:00-10:00 (20)	Filters & Purifiers (TF) 10:00-11:00 (20)	Mass Flow Controller (TF) 11:00-12:00 (20)		Gases Specification (TF) 13:00-14:00 (20)		Heater Jacket (TF) 15:00-16:00 (20)					
Information & Control						(By Invitation Only) NA I&C Leadership 12:00-13:00 (10)	(By Invitation Only) I&C (GCS) 13:00-13:30	GEM300 (TF) 13:30-16:00 (20)		Advanced Backend Factory Integration (TF) 16:00-18:00 (15)				
Liquid Chemicals							(By Invitation Only) NA Liquid Chemicals Leadership 13:00-14:00 (15)	Chemical Analytical Methods (CAM) (TF) 14:00-15:00 (25)		CMP-Consumables (TF) 15:30-16:30 (25)				
MEMS/NEMS				Joint SEMI MSIG WG, MEMS Material Characterization (TFs) [MEMS/NEMS (C) POSTPONED] 10:00-11:30 (10)										
Silicon Wafer							Int'l Automated Advanced Surface Inspection (TF) 13:00-14:00 (20)		Int'l Advanced Wafer Geometry (TF) 14:00-17:00 (20)					
Traceability			5-Year Review (TF) 8:30-9:30 (15)	Equipment and Materials Traceability (TF) (15) 09:30-10:30		Single Device Traceability (TF) 11:00-12:00		POSTPONED Traceability (C) 14:00-16:00						
Regional Standards Committee (RSC)													(By Invitation Only) NARSC Business Meeting 18:00-21:00 (35)	

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Tuesday, March 31, 2020

U.S. Pacific Time	7:00	8:00	9:00	10:00	11:00	12:00	13:00	14:00	15:00	16:00	17:00	18:00	19:00	20:00
Environmental Health & Safety			S10 (Risk Assessment) Revision (TF) 09:00-10:00 (20)	S2 (Pressure Guideline) Revision (TF) 10:00-11:30 (20)			S2 Chemical Exposure (TF) 13:00-14:30 (20)				Energy Materials EHS (TF) 17:00-17:30 (20)			
Facilities & Gases			POSTPONED Facilities & Gases (C) 09:00-12:00 (25)											
Information & Control			Process Control Systems (PCS) (TF) 09:00-10:00 (10)		Fab & Equipment Computer and Device Security (CDS) (TF) 11:00-13:00 (15)		Diagnostic Data Acquisition (DDA) (TF) 13:00-17:30 (25)							
			Energy Saving Equipment Communication (ESEC) (TF) 09:00-10:30 (15)											
Liquid Chemicals			UPW & Water Management (TFs) 08:00-09:30 (25)	High Purity Polymer Materials & Components (TF) 09:30-10:30 (25)			POSTPONED Liquid Chemicals (C) 14:00-17:00 (25)							
Metrics							ESD/ESC (TF) 13:00-14:30 (10)			RF Measurements (TF) 16:00-17:00 (15)				
PIC							Electron Microscopy Workflow (TF) 13:00-15:00 (15)		Panel Level Packaging (PLP) Panel FOUF (Japan TF) 15:00-17:00 (15)					
Silicon Wafer			POSTPONED Silicon Wafer (C) 09:00-12:00 (25)											
Other											Canceled Standards Networking Event 17:30 - 19:00 (100)			

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Wednesday April 1, 2020

U.S. Pacific Time	7:00	8:00	9:00	10:00	11:00	12:00	13:00	14:00	15:00	16:00	17:00	18:00	19:00	20:00
Environmental Health & Safety			S8 (Ergonomics) Revision (TF) 09:00-10:00 (20)				Control of Hazardous Energy (TF) 12:30-13:30 (20)							
Information & Control														
Metrics														
PIC														

POSTPONED

Information & Control (I&C) (C)
08:00-14:00 (25)

Equipment RAMP Metrics
(TF)
09:00-11:00 (15)

Critical
Chamber
Components
(CCC) (TF)
12:30-13:30
(10)

POSTPONED
Metrics (C)
15:30-18:00 (20)

POSTPONED

Physical Interfaces &
Carriers (PIC) (C)
10:00-12:00 (15)

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Thursday April 2, 2020

U.S. Pacific Time	7:00	8:00	9:00	10:00	11:00	12:00	13:00	14:00	15:00	16:00	17:00	18:00	19:00	20:00
3D Packaging and Integration					3DP&I Joint Bonded Wafer Stacks and Inspection & Metrology (TFs) 11:00-12:00 (15)			Panel Level Packaging (PLP) Panel (TF) 13:30-14:30 (15)		POSTPONED 3D Packaging & Integration (C) 14:00-16:00 (15)				
Environmental Health & Safety								POSTPONED Environmental, Health & Safety (EH&S) (C) 09:00-18:00 (50)						